



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Dalton et al.

Attorney Docket No.:  
NOVLP082/NVLS-2893

Application No.: 10/772,109

Examiner: Jarrett Stark

Filed: February 3, 2004

Group: 2823

Title: USE OF METALLOCENES TO INHIBIT  
COPPER OXIDATION DURING  
SEMICONDUCTOR PROCESSING

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on February 15, 2007 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed: \_\_\_\_\_

Valerie Olsen

**AMENDMENT D**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is in response to the Office Action dated November 16, 2006 and accompanies a Request for Continued Examination. Please amend the above-identified patent application as follows:

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks/Arguments** beginning on page 5 of this paper.